

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

PATENT APPLICATION

*AF #*  
*2/3/04/01*

In re the Application of

Makoto KOBAYASHI et al.

Application No.: 09/830,434

Filed: April 26, 2001

For: POLISHING PAD AND POLISHING METHOD FOR SEMI-CONDUCTOR WAFER



Group Art Unit: 3723

Examiner: H. Shakeri

Docket No.: 109352

**NOTICE OF APPEAL TO THE BOARD OF  
PATENT APPEALS AND INTERFERENCES**

**RECEIVED**

FEB 23 2004

TECHNOLOGY CENTER R3700

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Applicants hereby appeal to the Board of Patent Appeals and Interferences from the Decision of the Primary Examiner dated November 21, 2003.

The \$330.00 Appeal Fee (\$165.00 Small Entity) is:

X

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Not required (fee paid in prior appeal in this  
application with no Board Decision on the merits).

The Commissioner is hereby authorized to charge any fees which may be required or credit any overpayment to Deposit Account No. 15-0461. Two duplicate copies of this document are enclosed.

Respectfully submitted,

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WPB:CWB/rav  
Date: February 19, 2004

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